

## EAST Search History

| Ref # | Hits  | Search Query                                       | DBs   | Default Operator | Plurals | Time Stamp       |
|-------|-------|--|---|------------------|---------|------------------|
| L1    | 3650  | ((si or silicon) near wafer\$1) same resistivit\$3 | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | ADJ              | ON      | 2006/10/29 11:21 |
| L2    | 16283 | concentration near carbon                          | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | ADJ              | ON      | 2006/10/29 11:21 |
| L3    | 44    | 1 and 2  | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | ADJ              | ON      | 2006/10/29 11:21 |